



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : 10/780,183 : Confirmation No.: 1740
Applicant : Hochberg et al.
Filed : 2/17/2004
For : PRECURSORS FOR DEPOSITING SILICON-CONTAINING FILMS
AND PROCESSES THEREOF

Art Unit : 2814
Examiner : Shrinivas H. Rao

Docket No. : 06417 USA
Customer No. : 23543

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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Response

Sir:

The following is responsive to the Office Action dated March 15, 2005:

- ☒ A 2 extension of time is requested and authorization to charge the Account of assignee is provided in an enclosed form.
- ☐ **Amendments to the Specification** begin on page _____ of this paper.
- ☒ **Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.
- ☐ **Amendments to the Drawings** begin on page _____ of this paper and include an attached replacement sheet(s).
- ☐ **Amendments to the Abstract** are on page _____ of this paper. A clean version of the Abstract is on page _____ of this paper.
- ☒ **Remarks/Arguments** begin on page 5 of this paper.